

The
United
States
of
America



United States Patent

Granted on January 1, 1963 to

Robert C. Nemeth

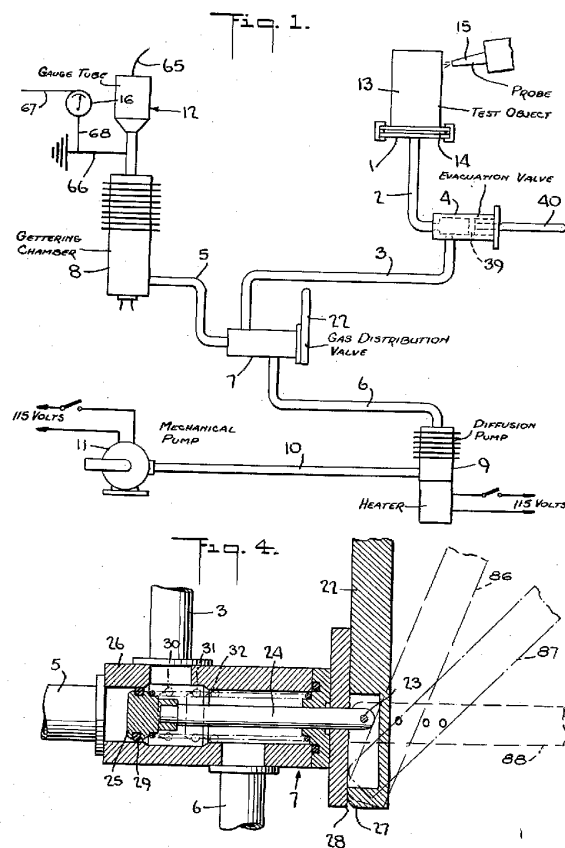
-INVENTOR-

Patent No. 3,070,992

Vacuum Instrument Corporation

PRESSURE GAUGE AND METHOD OF OPERATION

This invention relates to partial pressure gauges in general and more particularly to pressure gauges which can be used as pressure gauges per se on high vacuum pumps as part of a leak detecting system and also as part of a gas detecting system to distinguish active from inert gases.



The Commissioner of Patents and Trademarks has received an application for a patent for a new and useful invention. The requirements of law have been complied with, and it has been determined that a patent on the invention shall be granted under the law. Therefore, this

United States Patent

grants to the person or persons having title to this patent the right to exclude others from making, using or selling the invention throughout the United States of America for the term of seventeen years from the date of this patent, subject to the payment of maintenance fees as provided by law.

Daniel S. Larkin

Acting Commissioner of Patents

